



IFW

PATENT
8040-1059

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Wataru HATTORI Conf. 2934

Application No. 10/501,762 Group 2812

Filed July 19, 2004 Examiner Savitri Mulpuri

METHOD OF MANUFACTURING SURFACE
ACOUSTIC WAVE DEVICE AND
SEMICONDUCTOR DEVICE

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 23, 2005

Sir:

This responds to the Official Action of May 27, 2005.

Remarks begin on page 2 of this paper.

An **Appendix** is attached which follows the signature page of this paper.

Make of record the accompanying verified translation of Japanese priority application No. 2002-8501, filed January 17, 2002.